



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kiyoshi ARITA et al.

Serial No.: 10/036,485

Filed: January 7, 2002

For: PLASMA PROCESSING METHOD

Group Art Unit: 2829

Examiner: Scott B. Geyer

AMENDMENT

Mail Stop Non-Fee Amendment  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed August 27, 2003,  
please amend the above-identified application as follows:

PLEASE ACCEPT THIS AS  
AUTHORIZATION TO DEBIT  
OR CREDIT FEES TO  
DEP. ACCT. 16-0331  
PARKHURST & WENDEL

RECEIVED  
NOV 19 2003  
TECHNOLOGY CENTER 2800